

PATENT

46379

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Takashi FUJII et al. :
Serial No.: *not yet received* :
Filed: *herewith* :
For: PROCESS FOR PRODUCING COLD FIELD- :
EMISSION CATHODES :

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Preliminary to examination and calculation of the filing fee, please amend the above-identified application, as follows: